



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4091**
Kazuto HIROKAWA et al. : Docket No. 2003_0961A
Serial No. 10/617,794 : Group Art Unit 3723
Filed July 14, 2003 : Examiner Eileen P. Morgan

SUBSTRATE POLISHING APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Restriction Requirement of March 24, 2005, please amend the above-identified application as follows: